

# Advanced Light Management and Passivation Strategies in Ultrathin CIGS Solar Cells

Loukiana KOZLOV<sup>1,2</sup>, Thomas BIDAUD<sup>1,2</sup>, Sylvain FINOT<sup>2,3</sup>, Javid HAJHEMATI<sup>1</sup>, Aleksandra BOJAR<sup>1,2</sup>, Amelle REBAI<sup>3</sup>, Negar NAGHAVI<sup>1</sup>, Stéphane COLLIN<sup>1,2</sup>

<sup>1</sup> IPVF-CNRS UMR 9006, Institut Photovoltaïque d'Ile-de-France, 91120 Palaiseau, France

<sup>2</sup> C2N, Centre de Nanosciences et de Nanotechnologies, 91120 Palaiseau, France

<sup>3</sup> IPVF, Institut Photovoltaïque d'Ile-de-France, 91120 Palaiseau, France

This work is based on Cu(In,Ga)Se<sub>2</sub> (CIGS) polycrystalline material as light absorber in thin films solar cells. In order to reduce costs and save materials, we are aiming to reduce the absorber thickness from 2.5  $\mu\text{m}$  to 0.5  $\mu\text{m}$ , while increasing efficiency. CIGS is usually deposited by co-evaporation on Molybdenum back contacts which withstands the high (up to 500°C) deposition temperature. However, the CIGS/Mo interface has a low reflectivity and is prone to charge recombination, resulting in poor performances in ultrathin CIGS solar cells. This poses the challenge of finding a stable, highly reflective and passivating material for the back contact. Here, we present novel back contacts with two purposes: passivation of the back interface and increase of light absorption.

Our approach aims to enhance photon absorption in ultrathin CIGS absorbers ( $\sim 0.5 \mu\text{m}$ ) by integrating tailored light-scattering nanostructures at the substrate level. These nanopatterns are designed using computational modeling and fabricated via nanoimprint lithography. They are combined with an optimized transparent conductive back contact (ITO) and/or thermally stable reflective mirrors, which maintain up to 90% reflectance under the high-temperature conditions typical of CIGS deposition [1].

Our recent results demonstrate the effectiveness of our approach made of an ITO back contact covered by a nano-imprinted SiO<sub>2</sub> layer with periodic openings (Fig. 1). It leads to improvements in both Voc (+60 mV) and Jsc (+5 mA/cm<sup>2</sup>) with respect to conventional Mo back contacts, thereby enhancing overall cell performances. The Voc improvement is attributed to a reduction in the contact area with the conductive oxide (localized CIGS/ITO contacts) and a low recombination velocity at the CIGS/SiO<sub>2</sub> interface. The Jsc improvement is due to the combination of a reflective mirror and the diffractive effect of the periodic holes [2].

A thin (<60 nm) SiO<sub>2</sub> layer was used in these experiments. According to optical simulations, further improvements can be obtained with optimized period, width and thickness of the patterned layer. Ongoing experiments should also provide additional insights on the remarkable passivation properties of this localized back contacts.

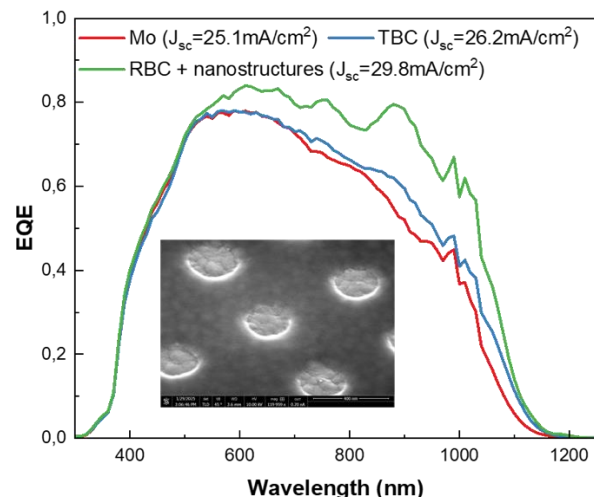


Figure 1 : External Quantum Efficiency measurements for 0.5 $\mu\text{m}$  CIGS cells on Mo, Transparent Back Contact (TBC) and Reflective Back Contact (RBC) with nanostructures. Inset: SEM image of the nanostructures (holes in a SiO<sub>2</sub> layer on ITO).

## References

[1] Louis Gouillart, Wei-Chao Chen, Andrea Cattoni, Julie Goffard, Lars Riekher, Jan Keller, Marie Jubault, Negar Naghavi, Marika Edoff, Stéphane Collin, "Interface Engineering of Ultrathin Cu(In,Ga)Se<sub>2</sub> solar cells on reflective back contacts," **Progress in Photovoltaics: Research and Applications** **29**, 212-221, 2021.

[2] Inès Massiot, Andrea Cattoni, and Stéphane Collin, "Progress and prospects for ultrathin solar cells" **Nature Energy** **5**, 959-972, 2020.